



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: KEVIN R. LENSING

Serial No.: 09/897,205

Filed: July 2, 2001

For: METHOD OF USING SCATTEROMETRY

MEASUREMENTS TO CONTROL PHOTORESIST ETCH PROCESS

Group Art Unit: 2876

Examiner: Kumiko C. Koyama

Atty. Dkt. No.: 2000.071900/TT4369

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

CERTIFICATE OF MAILING 37 C.F.R 1.8

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on the date below:

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

April 22, 2003

Date

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, it is respectfully requested that this Supplemental Information Disclosure Statement be entered and the documents listed on attached Form PTO-1449 be considered by the Examiner and made of record. Copies of the listed documents required by 37 C.F.R. § 1.98(a)(2) are enclosed for the convenience of

In accordance with 37 C.F.R §§ 1.97(g),(h), this Supplemental Information Disclosure Statement is not to be construed as a representation that a search has been made, and is not to be construed to be an admission that the information cited is, or is considered to be, material to patentability as defined in 37 C.F.R. § 1.56(b).

04/29/2003 MBIZUNES 00000125 010365 09897205

the Examiner.

01 FC:1806

180.00 CH

The Assistant Commissioner is hereby authorized to deduct the fee as set forth in 37 C.F.R. § 1.17(p) in the amount of \$180.00 from Advanced Micro Devices, Inc.'s Deposit Account 01-0365/TT4369. In the event the monies in that account are insufficient, the Assistant Commissioner is authorized to withdraw funds from Williams, Morgan & Amerson, P.C. Deposit Account No. 50-0786/2000.071900.

Applicant respectfully requests that the listed documents be made of record in the present case.

Date: April 22, 2003

23/2U
PATENT TRADEMARK OFFICE

Respectfully submitted,

J. Mike Amerson Reg. No. 35,426

WILLIAMS, MORGAN & AMERSON

10333 Richmond, Suite 1100

Houston, Texas 77042

(713) 934-4055

(713) 934-7011 (facsimile)

ATTORNEY FOR APPLICANT

Form P	TO-1449 (modified)
OIP List of P	atents and Publications for Applicant's
	SUPPLEMENTAL
APR 2 8 2003 S	DRMATION DISCLOSURE STATEMENT

Atty. Docket No. 2000.071900/TT4369

Serial No. 09/897,205

Applicant

KEVIN R. LENSING

(Use several sheets if necessary)

Filing Date: July 2, 2001 Group: 2876

U.S. Patent Documents

See Page 1

Foreign Patent Documents

See Page 1

Other Art See Page 1

U.S. Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Name	Class	Sub Class	Filing Date of App.
	A1	6,433,878 B1	08/13/02	Niu et al.	356	603	
	A2	US 2002 0135781 A1	09/26/02	Singh et al.	356	601	
	A3				- 4		
	A4						
	A5				_		

Foreign Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Country	Class	Sub Class	Translation Yes/No
	B1						
	B2						
	В3						

Other Art (Including Author, Title, Date Pertinent Pages, Etc.)

Exam. Init.	Ref. Des.	Citation
	C1	
	C2	TE
	C3	TECHNO
		RECEIVED APR 30 2003 CLOSY CENTER 2800

EXAMINER:

DATE CONSIDERED:

EXAMINER: INITIAL IF REFERENCE CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED. INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.